

In the Claims:

a<sup>1</sup>  
Claim 1 (amended). A thin film piezoelectric resonator,  
comprising:

a lower electrode layer and an upper electrode layer;

a piezoelectric layer between said lower electrode layer and  
said upper electrode layer;

an additional layer disposed on said upper electrode layer,  
said additional layer being structured with etching structures  
for setting a prescribed resonant frequency of the  
piezoelectric resonator.